

<b>Notice of References Cited</b>	Application/Control No. 10/798,549		Applicant(s)/Patent Under Reexamination DUAN ET AL.	
	Examiner Chih-Min Kam		Art Unit 1656	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0031734 A1	02-2005	Duan et al.	426/020
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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